

Erratum to: Measurement of copper vapour laser-induced deformation of dielectric-coated mirror surface by Michelson interferometer

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The original publication of this article (DOI: 10.1007/s12043-014-0704-y) which appeared in *Pramana – J. Phys.* **82(2)**, 445 (2014), unfortunately contains an error. Figure 4 is not correct, and the correct figure is reproduced here in its entirety.

The authors apologize for this error.

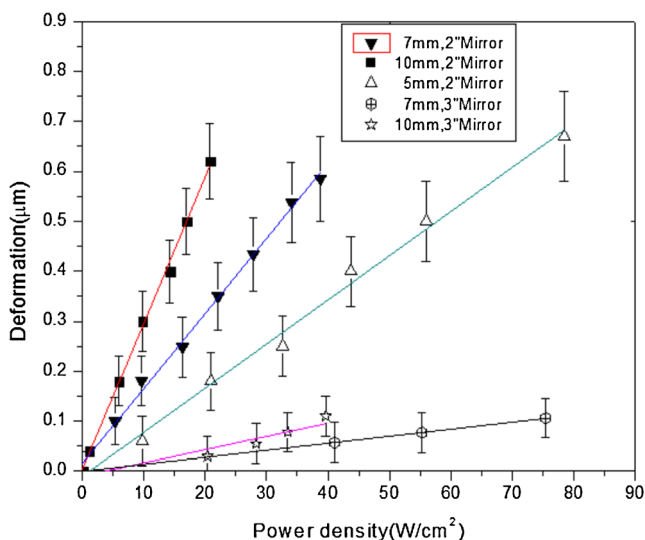


Figure 4. Deformation vs. average power density for mirrors with BK7 substrate. The inset data show spot size and mirror diameter.